Ultrasmall in-plane demultiplexer enabled by an arrayed one-dimensional photonic crystal nanobeam cavity

Daquan Yang
Xin Chen
Xuan Zhang

Ultrasmall in-plane demultiplexer enabled by an arrayed one-dimensional photonic crystal nanobeam cavity

Daquan Yang,a,b,* Xin Chen,a and Xuan Zhanga

aBeijing University of Posts and Telecommunications, School of Information and Communication Engineering, Beijing, China
bBeijing University of Posts and Telecommunications, State Key Laboratory of Information Photonics and Optical Communications, Beijing, China

Abstract. We propose a design for silicon-on-chip integrated eight-channel wavelength division multiplexing (WDM) demultiplexer, which consists of parallel-arrayed one-dimensional (1-D) photonic crystal nanobeam cavities (PCNCs) with high-Q over 105 and large free spectral range of \( \sim 200 \) nm. To the best of our knowledge, this is for the first time that a 1-D PCNC-based demultiplexer is presented. The performance of the device is investigated theoretically by using three-dimensional finite-difference time-domain method. To enable eight-channel parallel arrayed 1-D PCNCs to be coupled to on-chip optical networks for higher integration and multiplex application, an \( 1 \times 8 \) taper-type equal optical power splitter is used to connect all channels simultaneously. The total device footprint is as small as 12 \( \mu m \times 15 \) \( \mu m \) (width \( \times \) length), which is decreased by five times compared to that per channel in the recent two-dimensional (2-D) PC-based demultiplexer. Moreover, the average channel spacing smaller than 115 GHz is achieved, which is more than two times smaller than that of 2-D PC nanocavity devices, demonstrating that the arrayed nanocavities have the potential for developing ultracompact 100-GHz spaced filters in a dense WDM system. Thus, we believe that the results demonstrated in this work is promising for the future on-chip photonics integrated circuits and optical communication systems.© The Authors. Published by SPIE under a Creative Commons Attribution 3.0 Unported License. Distribution or reproduction of this work in whole or in part requires full attribution of the original publication, including its DOI. [DOI: 10.1117/1.OE.57.10.107103]

Keywords: one-dimensional photonic crystals nanobeam cavities; wavelength division multiplexing demultiplexer; optical interconnects; silicon nanophotonics.

Paper 181059 received Jul. 23, 2018; accepted for publication Sep. 26, 2018; published online Oct. 20, 2018.

1 Introduction

Over the past decades, with the increasing demand for bandwidth, it has become a significant trend to develop optics communication systems for large-capacity and high-efficiency data transmission. Wavelength division multiplexing (WDM) technology plays a very important role in longhaul optics communication systems because it supports large-capacity data transmission with high reliability.1–6 So far, a variety of optical WDM demultiplexers used in silicon (Si) photonics have been proposed and demonstrated, such as Si microring demultiplexers,7 Si arrayed waveguide gratings (AWG) demultiplexers,8–10 Si multimode interference (MMI) demultiplexers,11,12 and Si Mach–Zehnder switches demultiplexers.13–15 However, the footprint of these WDM demultiplexers is too large, and therefore difficult to integrate with other nanoscale optical components. Thus, recently attention has turned to developing on-chip compact WDM demultiplexers with an ultrasmall footprint.6

Silicon photonic crystals (PC), artificial periodic structures with high refractive index contrast in dielectric media, and a periodicity in the wavelength scale of light have attracted great interest because of their potential to control light propagation effectively in a short distance, which can lead to very compact devices. Consequently, silicon PC is a promising candidate for achieving ultracompact WDM demultiplexers. To realize smaller WDM demultiplexers, those based on Si PC are being developed.17–24 For example, Song et al.18 demonstrated two-dimensional (2-D) PC cavities-based 16-channel WDM demultiplexer with 628-GHz channel spacing, and the footprint of per channel is 12 \( \mu m^2 \). Takahashi et al.21 demonstrated 2-D PC cavities-based 32-channel out-of-plane WDM demultiplexer with 100-GHz channel spacing, and the footprint of per channel is \( \sim 130 \) \( \mu m^2 \). Ooka et al.26 demonstrated 2-D PC cavities-based eight-channel in-plane WDM demultiplexer with 267-GHz channel spacing, and the footprint of per channel is 110 \( \mu m^2 \). Among these Si PC-based WDM demultiplexers mentioned above, all of them are based on 2-D PC cavity platforms.

Compared with 2-D PC cavities, one-dimensional (1-D) PC nanobeam cavities (PCNCs) have been recently demonstrated as a competitive platform for large-scale on-chip photonic integration, owing to their attractive properties of ultracompact footprint, ultrahigh \( Q/V \) (\( Q \) and \( V \) are cavity quality factor and mode volume, respectively), and high integrability with optical bus-waveguides and circuits.22–26 Thus, to achieve an ultracompact WDM demultiplexer with much smaller footprint, a method for the dense integration of ultracompact 1-D PCNCs-based WDM demultiplexer is proposed on a monolithic silicon chip. The proposed demultiplexer device consists of multiple channels of parallel-arrayed 1-D PCNCs units. The adjacent channels are separated with small air-gap separations. Each channel consists of a high-Q 1-D PCNC with different cavity length to extract transmitted light with a specific resonant wavelength. To enable all parallel-arrayed 1-D PCNCs units to be interrogated simultaneously, a \( 1 \times N \) equal power splitter is used in the input port of the device. The performance of the device is investigated theoretically by using three-dimensional finite-difference time-domain (3-D FDTD) simulation (a commercial software package, Lumerical FDTD Solutions). The results show that the presented eight-channel WDM demultiplexer with 100-GHz channel spacing and \( Q/V = 10^5 \) could be implemented on a monolithic silicon chip.
demultiplexer with dense channel spacing smaller than 115 GHz is achieved. Moreover, the footprints per channel are 22.5 μm², which is decreased by more than five times compared to the per channel in the recent 2-D PC-based WDM demultiplexers. In addition, it is worth mentioning that, by changing the cavity length on the subnanometer scale, the peak wavelengths at 100-GHz spacing in the wavelength range between 1330 and 1420 nm can be successfully designed, which is potentially a promising platform for developing ultracompact 100-GHz spaced dense WDM system with more than 100 channels.

The paper is organized as follows. Section 2 describes the design of the proposed eight-channel WDM demultiplexers based on parallel-arrayed 1-D PCNC units. Section 3 shows the performance discussion and analysis of the proposed WDM demultiplexers based on the results obtained by using 3-D FDTD. Section 4 draws a brief conclusion of the paper.

2 Design

Figure 1(a) shows the proposed eight-channel WDM demultiplexer in the upper 220-nm-thick silicon layer of a silicon-on-insulator (SOI) substrate. The refractive index of the silicon layer and silica substrate is n_Si = 3.46 and n_SO2 = 1.45, respectively. A 1×8 optical power splitter (OPS) divides the input signal power into eight channels, respectively. The width of OPS (w_in) is 12 μm and the length of tapered waveguide (l taper) is 10 μm. And the input port width of the eight tapered silicon waveguides are 4.60, 1.15, 0.89, 0.86, 0.86, 0.89, 1.15, and 4.60 μm from top to bottom. By using 3-D FDTD method, Fig. 2 shows the composed transmission spectra of each output port in the proposed 1×8 OPS. It is worth mentioning that the insertion loss includes the coupling losses, the excess losses, and the propagation losses. All the insertion losses for each output port of the proposed 1×8 OPS at wavelength of ~1550 nm are 9.61, 9.64, 9.86, 9.83, 9.83, 9.86, and 9.64, and 9.61 dB, respectively, which are the best values obtained from the optimized simulation. The excess loss is 0.69 dB. We have also captured the output profiles of the 1×8 OPS. The inset in Fig. 2 is the cross-section of electric field profile for the fundamental TE-like mode propagating through the output ports of the splitter in y−z plane. It can be seen that the field intensity of each output is nearly uniform. And the calculated output uniformity of the splitter at a wavelength of ~1550 nm is better than 0.25 dB.

The 1-D PCNC arrays consists of eight parallel-arrayed 1-D PCNC units separated by air-gap. A single 1-D PCNC unit is shown in Fig. 1(b), which consists of a single 1-D PCNC units separated by air-gap. A single 1-D PCNC unit is that each unit has a different cavity length (l_c), respectively. The only difference among these eight parallel-arrayed 1-D PCNC units is that each unit has a different cavity length (l_c1, l_c2, l_c3, l_c4, l_c5, l_c6, l_c7, and l_c8) referring to the cavity length of cavity unit 1, 2, 3, 4, 5, 6, 7, and 8, respectively, being 1, 2, 3, 4, 5, 6, 7, and 8, respectively. All the air-hole gratings radii in the tapered region that are the same linearly decreased from inside to outside as 310, 290, 270, and 250 nm, respectively. Next, we introduce a defect region into the cavity by gradually increasing the periodicity (hole-to-hole distance) and hole diameter for each segment starting from a pair of outer holes and symmetrically moving toward the center. When the feature size of a segment is enlarged, the band-gap is redshifted, resulting in a graded photonic band, as shown in Fig. 3. This allows confining a resonant mode in the defect region: the resonant mode is coupled to the evanescent Bloch modes within the photonic band-gaps (PBG) in the cavity center, effectively trapping it between a pair of Bragg mirrors. Here, the number of the air-hole gratings (N_m) in the mirror region and the number of the air-hole gratings (N_f) in the tapered region of each unit are the same as N_m = 5 and N_f = 4, respectively. And the air-hole gratings radii (r) and the periodicity (a) in the mirror region are the same as r = 85 nm and a = 350 nm, respectively. All the air-hole gratings radii in the tapered region that are the same linearly decreased from inside to outside as 95, 80, 65, and 50 nm, respectively; all the periodicities in the tapered region that are the same linearly decreased from inside to outside as 310, 290, 270, and 250 nm, respectively. The only difference among these eight parallel-arrayed 1-D PCNC units is that each unit has a different cavity length (l_c1, l_c2, l_c3, l_c4, l_c5, l_c6, l_c7, and l_c8) referring to the cavity length of cavity unit 1, 2, 3, 4, 5, 6, 7, and 8, respectively, being 1, 2, 3, 4, 5, 6, 7, and 8, respectively. Being 1 the unit at the top channel and 8 the unit at the bottom.
channel) to extract transmitted light with a different wavelength ($\lambda_1$, $\lambda_2$, $\lambda_3$, $\lambda_4$, $\lambda_5$, $\lambda_6$, $\lambda_7$, and $\lambda_8$). Here, the cavity length ($l_c$) is defined as the distance between the two adjacent air holes in the cavity center [Fig. 1(b)]. As seen in Fig. 1(c), the optical field is well-localized in the dielectric zone between the two center holes.

The $Q$-factors optimization of a single 1-D PCNC unit by using 3-D FDTD is shown in Fig. 4. The number of the air-hole gratings in the mirror section and the number of the air-hole gratings in the tapered section are investigated in detail. The optimized $Q$-factor of a 1-D PCNC unit over $10^5$ can be achieved. The $Q$ value is higher than that obtained with an $L_n$ nanocavity ($\sim 10^3$)\textsuperscript{21} and width-modulated nanocavity ($\sim 10^4$)\textsuperscript{24} in 2-D PC slabs. In this work, in order to save the simulation time of the transmission calculation, we used a high transmission but low $Q$ geometry: the number of gratings was chosen to be $N_m = 5$, and $N_t = 4$ in the mirror region and taper region, respectively. Figure 5 summarizes the calculated cavity resonant wavelength and free spectral range (FSR) as a function of the cavity length changed from $l_c = 300$ nm to $l_c = 500$ nm. As expected, with the cavity length increased, the cavity resonant wavelength moves toward longer wavelength, due to the increase in high-dielectric material in the cavity center region.\textsuperscript{39} As seen, with proper engineering of the cavity length of 1-D PCNC unit, an arbitrary resonant wavelength ranging from 1240 to 1430 nm can be obtained, indicating that WDM demultiplexer can be operated with flexible design. In addition, the cavity FSR increases with the increasing cavity length. When the cavity length $l_c = 500$ nm, the cavity FSR as large as 197 nm can be achieved, which is significantly increased compared to previous design,\textsuperscript{40} indicating that a wide enough bandwidth is provided to design a WDM demultiplexer with as many channels as possible. This indicates that a dense WDM demultiplexer can be achieved. Here, it is worth mentioning that the footprint

![Diagram of tapered PBG for a typical 1-D PCNC unit with cavity length $l_c = 350$ nm.](https://www.spiedigitallibrary.org/journals/Optical-Engineering)

Fig. 3 Diagram of tapered PBG for a typical 1-D PCNC unit with cavity length $l_c = 350$ nm.

![3-D FDTD calculated $Q$-factors as a function of (a) the number of the air-hole gratings ($N_m$) in the mirror section changed from $N_m = 2$ to $N_m = 22$, while the number of the air-hole gratings ($N_t$) in the tapered section is kept fixed as $N_t = 2$; and (b) the number of the air-hole gratings ($N_t$) in the tapered section changed from $N_t = 2$ to $N_t = 10$, while the number of the air-hole gratings ($N_m$) in the mirror section is kept fixed as $N_m = 21$.](https://www.spiedigitallibrary.org/journals/Optical-Engineering)

![Fig. 4 3-D FDTD calculated $Q$-factors as a function of (a) the number of the air-hole gratings ($N_m$) in the mirror section changed from $N_m = 2$ to $N_m = 22$, while the number of the air-hole gratings ($N_t$) in the tapered section is kept fixed as $N_t = 2$; and (b) the number of the air-hole gratings ($N_t$) in the tapered section changed from $N_t = 2$ to $N_t = 10$, while the number of the air-hole gratings ($N_m$) in the mirror section is kept fixed as $N_m = 21$.](https://www.spiedigitallibrary.org/journals/Optical-Engineering)
of a single 1-D PCNC unit is ultracompact as small as ~3 μm² [with \( l_c = 500 \text{ nm} \), \( N_m = 5 \), and \( N_t = 4 \) shown in Fig. 1(b)], which is decreased more than one order of magnitude compared with previous designs based on 2-D PC nanocavities (~100 μm²). Thus, the proposed parallel-arrayed 1-D PCNC units with high \( Q \), large FSR, and ultra-small footprint is potentially a promising platform for high-density integrated dense WDM design and on-chip integrated WDM optical communication systems.

3 Discussion

3-D FDTD simulations are performed to numerically study the performances of the proposed eight-channel WDM demultiplexer based on parallel-arrayed 1-D PCNC units. There is a linear relationship between the cavity length and the output wavelength (\( \lambda \)). In this work, in order to obtain uniform channel spacing, the cavity length of each cavity unit in the channel from top to bottom is \( l_1 = 409.0 \text{ nm} \), \( l_2 = 409.8 \text{ nm} \), \( l_3 = 410.6 \text{ nm} \), \( l_4 = 411.4 \text{ nm} \), \( l_5 = 412.2 \text{ nm} \), \( l_6 = 413.0 \text{ nm} \), \( l_7 = 413.8 \text{ nm} \), and \( l_8 = 414.6 \text{ nm} \), respectively. Figure 6 shows the composed transmission spectra of the proposed eight-channel WDM demultiplexer. As expected, the proposed device can divide the input light wavelength into eight different wavelengths with \( \lambda_1 = 1348.67 \text{ nm} \), \( \lambda_2 = 1349.36 \text{ nm} \), \( \lambda_3 = 1350.06 \text{ nm} \), \( \lambda_4 = 1350.75 \text{ nm} \), \( \lambda_5 = 1351.45 \text{ nm} \), \( \lambda_6 = 1352.14 \text{ nm} \), \( \lambda_7 = 1352.84 \text{ nm} \), and \( \lambda_8 = 1353.54 \text{ nm} \), where the uniform channel spacing is smaller than 115 GHz (<0.7 nm). The insertion losses of each output port of the proposed eight-channel demultiplexer at the corresponding resonant wavelength of \( \lambda_1, \lambda_2, \lambda_3, \lambda_4, \lambda_5, \lambda_6, \lambda_7, \) and \( \lambda_8 \) are 14.12, 14.28, 14.30, 14.33, 13.93, 13.19, 13.71, and 13.57 dB, respectively. The excess loss, namely the total loss, is 4.88 dB. The power division ratio, defined as the ratio of the minimum and maximum power of all output powers, is 1.14 dB. The channel isolation levels, defined as the level difference of the output power in all channels at the same resonant wavelength, are better than 10 dB for all the different resonant wavelengths of the proposed demultiplexer.

In addition, we compare the performance of our device with that of previously reported devices, as shown in Table 1. As seen, we find that the performance of the proposed WDM device based on parallel arrayed 1-D PCNC units is greatly improved compared with other silicon-based WDM devices. The average channel spacing and per-channel footprint are decreased by two times and five times, respectively, compared with that of the recent 2-D PC cavity-based WDM demultiplexer. In addition to the small footprint, the structural simplicity of the proposed demultiplexer in this paper lends itself to easier fabrication. The experimental realization of the proposed demultiplexer is generally technically achievable with modern nanofabrication technique, such as electron beam lithography (EBL) technique. Thus, the proposed demultiplexer structure can be experimentally achieved on an SOI platform using the EBL technique, as demonstrated in our previous work.

Moreover, it is worth mentioning that by changing the cavity length on the subnanometer scale, the peak

<table>
<thead>
<tr>
<th>Structure and platform</th>
<th>Nanocavity</th>
<th>Configuration</th>
<th>Number of channels</th>
<th>Average channel spacing</th>
<th>Footprint of per channel</th>
<th>Ref.</th>
</tr>
</thead>
<tbody>
<tr>
<td>AWG SOI</td>
<td>–</td>
<td>In-plane</td>
<td>8</td>
<td>250 GHz</td>
<td>1.7 \times 10^{-4} μm²</td>
<td>10</td>
</tr>
<tr>
<td>2-D PC SOI</td>
<td>( L_3 ) cavity</td>
<td>Out-of-plane</td>
<td>32</td>
<td>100 GHz</td>
<td>~130 μm²</td>
<td>21</td>
</tr>
<tr>
<td>2-D PC SOI</td>
<td>Width modulation cavity</td>
<td>In-plane</td>
<td>8</td>
<td>267 GHz</td>
<td>110 μm²</td>
<td>24</td>
</tr>
<tr>
<td>2-D PC SOI</td>
<td>Nanobeam cavity</td>
<td>In-plane</td>
<td>8</td>
<td>115 GHz</td>
<td>22.5 μm²</td>
<td>Present work</td>
</tr>
</tbody>
</table>

Note: SOI, silicon on insulator.
wavelengths at 100-GHz spacing in the wavelength range between 1330 and 1420 nm can be successfully controlled, as shown in Fig. 7, which is potentially a promising platform for developing ultracompact 100-GHz spaced dense WDM system with more than 100 channels. However, the insertion loss in the proposed demultiplexer will increase as the channel number increasing. To solve this problem, the feasible methods to minimize the insertion loss are as follows: (1) increasing the transmission efficiency of each channel by further optimizing the structure parameters of the 1-D PCNCs; (2) choosing other optical power splitters with extremely low insertion losses (e.g., MMI-based beam splitter\(^{125}\)) for the proposed 1-D PC-based demultiplexer to decrease the insertion loss.

### 4 Conclusion

We have proposed and numerically demonstrated an ultracompact in-plane eight-channel WDM demultiplexer with dense channel spacing smaller than 115 GHz and ultrasmall footprint of \(\sim100\) GHz can be observed in the wavelength ranging from (a) 1330 nm to 1380 nm and (b) 1380 nm to 1420 nm.

### Acknowledgments

The authors gratefully acknowledge the support from the National Natural Science Foundation of China (NSFC) (61501053); the Fundamental Research Funds for the Central Universities (2018XKJC05); and the Fund of the State Key Laboratory of Information Photonics and Optical Communications (IPOC2017ZT05), Beijing University of Posts and Telecommunications, China.

### References


Daquan Yang is an associate professor at the University of Posts and Telecommunications (BUPT). He received his BS degrees in electronic information science and technology from the University of Jinan in 2005, and his PhD in optics from BUPT in 2014. He is the author of more than 50 journal and conference papers. His current research interests include photonics crystal, optical microcavity sensors, and photonic integrated devices.

Xin Chen is a postgraduate student at the University of Posts and Telecommunications (BUPT). He received his BS degree in electronic information engineering from the Wuhan University in 2015. His current research interest is focused on nanofiber-based photonic crystal integrated devices and systems.

Xuan Zhang works at the School of Information and Communication Engineering at the University of Posts and Telecommunications (BUPT). She received her bachelor’s degree from Shandong University in 2008 and master’s degree from BUPT in 2011. Her current research focuses on photonic crystal sensors and devices.